

<b>Notice of References Cited</b>	Application/Control No. 10/564,359	Applicant(s)/Patent Under Reexamination HIROSAKI, NAOTO	
	Examiner C. Melissa Koslow	Art Unit 1793	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2006/0049414	03-2006	Chandran et al.	257/089
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	J. van Krevel, "On new rare-earth doped M-Si-Al-O-N materials", Chapter 6, pp. 73-87, 2000.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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